

# SIEMENS

PATENT  
Attorney Docket No. 2002P15759WOUS

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Inventor:	M. Appel, et al.	) Group Art Unit:	2612
		)	
Serial No.:	10/528,731	) Examiner:	Labbees, Edny
		)	
Filed:	03/22/2005	) Confirmation Number:	8587
Title:	METHOD AND APPARATUS FOR MONITORING A TECHNICAL INSTALLATION, ESPECIALLY FOR CARRYING OUT DIAGNOSIS		

Mail Stop AF  
**Commissioner For Patents**  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR 1.116

Sir:

In response to the Final Office Action mailed 27 January 2010, Applicants respectfully submit the following remarks traversing the art rejections and requesting allowance of the above-identified application.

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